

**Search Notes**

Application/Control No.

10/810,707

Examiner

Pranav V. Khatri

Applicant(s)/Patent under  
Reexamination

SHIRAISHI, TAKASHI

Art Unit

2872

**SEARCHED**

Class	Subclass	Date	Examiner
359	204	10/5/2005	PVK
359	212-216	10/5/2005	PVK
347	233-235	10/5/2005	PVK
347	243	10/5/2005	PVK
250	234-236	10/5/2005	PVK

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Consulted with Primary Examiner James Phan, recommended 359/204, 212-216 and 347/233-235,243, and 250/234-236.	10/3/2005	PVK
Consulted with Primary Examiner James Phan in regards to the final rejection strategy.	3/29/2006	PVK
Consulted with Primary Examiner Mark Robinson in regards to the final rejection strategy	3/30/2006	PVK